

Application/Control No.	Applicant(s)/Patent under Reexamination KAWANO, SEIICHI	
10/721,604		
Examiner	Art Unit	
Jeff Piziali	2629	

SEARCHED						
345	81,87- 89,94,101, 102,204,2 07	7/2/2007	J.P.			
345	214	7/2/2007	J.P.			
345	690-694	7/2/2007	J.P.			
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349	69-71	7/2/2007	J.P.			
250	552,553	7/2/2007	J.P.			
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INTERFERENCE SEARCHED					
Subclass	Date	Examiner			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST Search	7/2/2007	J.P.		